



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 28, 2026

IGI Report Number

LG794642551

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

11.87 X 6.01 X 3.72 MM

GRADING RESULTS

Carat Weight

1.49 CARAT

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG794642551

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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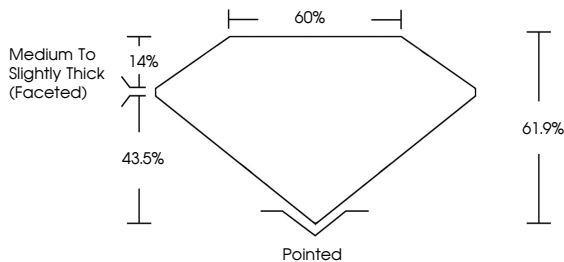
NONE

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PROPORTIONS



Medium To Slightly Thick (Faceted)

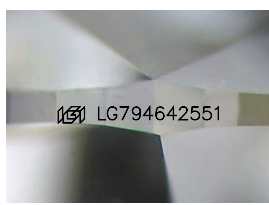
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43.5%

60%

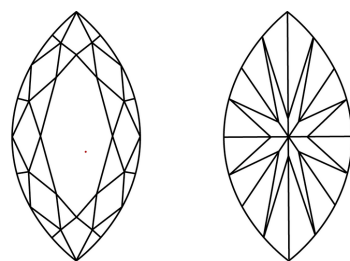
61.9%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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MARQUISE BRILLIANT

11.87 X 6.01 X 3.72 MM

Carat Weight

1.49 CARAT

Color Grade

F

Clarity Grade

VVS 2

Depth

61.9%

Table

60%

Girdle

Medium to Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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